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S/N 10/804,610

PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: KITAOKA, et al. Examiner: T. Ho  
Serial No.: 10/804,610 Group Art Unit: 2818  
Filed: March 18, 2004 Docket: 10873.1420US01  
Title: METHOD OF MANUFACTURING GROUP III NITRIDE  
SUBSTRATE AND SEMICONDUCTOR DEVICE

CERTIFICATE UNDER 37 CFR 1.6(d): I hereby certify that this paper is being transmitted by facsimile to the  
U.S. Patent and Trademark Office on April 18, 2006.

By:   
Name: Peggy Kerkhove

REQUEST FOR CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that this application be accorded the benefits of  
Continued Examination in accordance with the provisions of 37 C.F.R. §1.114.


☒ A submission meeting of requirements of 37 C.F.R. 1.111 accompanies this  
paper; or

☐ Please enter the amendment previously filed on but not entered.

Please charge the required filing fee of \$790.00 for a large entity to the Deposit  
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Respectfully submitted,

HAMRE, SCHUMANN, MUELLER &  
LARSON, P.C.  
P.O. Box 2902-0902  
Minneapolis, MN 55402-0902  
(612) 455-8800

By:   
Douglas P. Mueller  
Reg. No. 30,300

Dated: April 18, 2006

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